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Ultrashort intense-field optical vortices produced with laser-etched mirrors

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We introduce a simple and practical method to create ultrashort intense optical vortices for applications involving high-intensity lasers. Our method utilizes femtosecond laser pulses to laser etch grating lines into laser-quality gold mirrors. These grating lines holographically encode an optical vortex. We derive mathematical equations for each individual grating line to be etched, for any desired (integer) topological charge. We investigate the smoothness of the etched grooves. We show that they are smooth enough to produce optical vortices with an intensity that is only a few percent lower than in the ideal case. We demonstrate that the etched gratings can be used in a folded version of our 2f–2f setup [Opt. Express 19, 7599 (2005)] to compensate angular dispersion. Finally, we show that the etched gratings withstand intensities of up to $10^{12}$ W/cm$^2$. © 2007 Optical Society of America

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1. Introduction
Since the development of mode locking and chirped-pulsed amplification, intense and ultrashort laser pulses have been ubiquitously used in laboratories to study laser–matter interactions under extreme conditions [1,2]. What makes intense, ultrashort pulses so interesting is that peak intensities of $10^{15}$ W/cm$^2$ and more can be achieved. The corresponding electric fields result in a force on an atomic electron that is comparable to the force the nucleus exerts on it. Thus the pulse is capable of liberating an electron from its parent nucleus. Much research has been carried out in this area, known as intense-field ionization; some highlights are multiphoton ionization, tunneling ionization, and above threshold ionization [1,2].

Another field, evolved from research in wave-field dislocations [3] and laser modes within cavities [4], is known as singular optics [5]. An archetypical example of phase singularities in optics is the Laguerre–Gaussian (LG) [6] transverse paraxial beam mode $LG_{m=0}^{p}$, also known as the “donut mode” (here $m$ is the azimuthal mode number and $p$ is the radial mode number) [5,6]. LG modes have an azimuthal phase dependency of $\exp(i\theta)$ ($\theta$ is the azimuthal angle). This phase dependency causes the electric field to be undetermined on the optical axis [7]. Consequently, the field amplitude vanishes there; it is the location of an optical vortex (OV) with topological charge $m$ [5]. Ince–Gaussian modes [8,9] provide a connection between the Hermite–Gaussian [6] and the LG modes. Helical Ince–Gaussian (HIG) modes possess a number of vortices on a straight line. These modes were experimentally realized by symmetry breaking of a laser cavity [10] and later were also produced holographically [11]. The LG and HIG beams carry optical orbital angular momentum (OAM). Currently, in high-field physics there have been no experiments performed to investigate the effects of this quantity on atomic or molecular systems. Because we are interested in investigating possible effects of OAM in ionization processes, this paper is devoted to presenting a simple method to produce OAM-containing beams (in particular, OVs) by laser etching gratings lines into laser-quality mirrors.

Different methods have been devised to experimentally realize OVs in the laboratory. Among these methods are spiral phase plates (SPPs) [12–14] and methods based on computer-generated holograms
mode numbers states \(5,6\). The contributing LG modes have the OVs that are generally a superposition of pure LG light having a Gaussian intensity profile we obtain nating either of these elements with monochromatic gratings are typically used \[5,15,16,18\]. Upon illumini-...
skeleton equations. Setting $\Phi_0 = 0$ for simplicity and choosing $c = 1$ we obtain

$$m \arctan \left( \frac{y}{x} \right) = 2\pi Kx + \arccos(c)[\text{mod } 2\pi] = 2\pi(n + Kx). \quad (3)$$

The periodicity of the cosine function in Eq. (1) gives rise to the modulo term $2\pi n$ in Eq. (3), where $n = 0, \pm 1, \pm 2, \ldots$. This integer has a unique value for each grating line, so we call it the grating line number. If, in Eq. (3), we choose $m = 0$, the skeleton equations reduce to that of a straight-line grating $x = -n/K$, as shown in Fig. 2a. For nonzero (but integer) $m$ we solve Eq. (3) for $y$ to obtain the skeleton equations for the OV holograms:

$$y(x) = x \tan \left[ \frac{2\pi}{m}(n + Kx) \right]. \quad (4)$$

The periodicity of the tangent function in Eq. (4) gives unwanted branches in the solutions. We exclude these branches by setting conditions on the angular argument of the tangent function for three different regions of the grating plane: positive $x$ half-plane, negative $x$ half-plane, and the line $x = 0$. This latter line case will be discussed later. For the skeleton equations in the regions $x > 0$ and $x < 0$, we impose the following angular conditions ($\theta = \text{azimuthal angle}$):

$$x > 0 \quad \Rightarrow \quad \frac{1}{2} \pi < \theta < \frac{1}{2} \pi,$$

$$x < 0 \quad \Rightarrow \quad \frac{1}{2} \pi < \theta < \frac{3}{2} \pi. \quad (5)$$

Substituting the argument of the tangent function $\theta = 2\pi(n + Kx)/m$ in the inequalities of Eq. (5) we find the following conditions on the skeleton equations:

$$x > 0: \quad -\frac{1}{K} \left( \frac{m}{4} + n \right) \leq x \leq \frac{1}{K} \left( \frac{m}{4} - n \right), \quad n < \frac{m}{4},$$

$$x < 0: \quad -\frac{1}{K} \left( \frac{m}{4} - n \right) \leq x \leq \frac{1}{K} \left( \frac{3m}{4} - n \right), \quad n > \frac{m}{4}. \quad (6)$$

The last set of inequalities ($n < m/4$ and $n > m/4$) give the integer grating line numbers for which the first set of inequalities for $x$ hold. For the equation of the line $x = 0$, the argument of the tangent function is degenerate, namely,

$$\theta = \begin{cases} 
\frac{1}{2} \pi, & y > 0 \\
\text{undefined}, & y = 0 \\
-\frac{1}{2} \pi, & y < 0
\end{cases} \quad (7)$$

Again using $\theta = 2\pi(n + Kx)/m$, we rewrite Eq. (7) as

$$n = \begin{cases} 
\frac{m}{4}, & y > 0 \\
\text{undefined}, & y = 0 \\
-\frac{m}{4}, & y < 0
\end{cases} \quad (8)$$

Since $n$ is an integer $n = 0, \pm 1, \pm 2, \ldots$, Eq. (8) can apply only when $m = 0, \pm 4, \pm 8, \ldots$, and the straight line $x = 0$ needs to be considered only for these $m$ values. Note that if a value other than zero was chosen for $\Phi_0$, there could be a line in the positive $y$ half-plane and no line in the negative $y$ half-plane or vice versa. Summarizing, a grating that produces an OV beam can be drawn one line at a time by using Eq. (4) (skeleton equations), Eq. (6) (which places limits on the $x$ values), and Eq. (8) (for the center line, when needed). To verify that the equations are correct we drew the patterns seen in Fig. 2. We used the same line-by-line drawing approach to laser etch our mirror holograms—one groove at a time (see Section 3).

3. Grating Fabrication and Grating Quality

To laser etch the grating lines into the gold mirrors, we first built a motorized $X$-$Y$ translation stage. Two unmotorized translation stages (Standex, sensitivity 1 $\mu$m, maximum travel 150 mm) were mounted perpendicular to each other as shown in Fig. 3. The resulting $X$-$Y$ stage was used to move the mirror relative to the fixed focus of the laser beam. Stepper motors (Arrick Robotics, angular step size of 1.8°) were connected to the knobs of each of the translation stages via stainless steel bellow couplers. These couplers compensated for small misalignments between the stepper motors and the translation stages. The
stepper motors were connected to an Arrick Robotics MD-2 dual stepper motor driver that we controlled by a laboratory PC. Experimental tests showed that translations of 5 μm could be reliably reproduced. A schematic of the complete setup is shown in Fig. 3.

Laser radiation from a Spectra-Physics Spitfire Ti:sapphire laser having pulse durations of ~50 fs, center wavelength of 800 nm, and a maximum output power of ~2.3 W was used in the etching process. The laser beam was focused with an achromatic microscope objective having a magnifying power of 4.0×, numerical aperture of 0.2, and a focal length of 30.8 mm. The objective was independently mounted to a manually controlled vertical translation stage above the motorized X–Y translation stage. The manual translation stage allowed for micrometer positioning of the focus onto the mirror surface.

We used MATLAB code along with the line equations and their limits discussed in Section 2 to create two matrices, one encoding for x translations and the other encoding for y translations. Each column of the matrices was labeled by individual grating lines. These matrices were digitized into steps of 5 μm. LabVIEW code was used to interpret these matrices and subsequently control the movement of the translation stages.

The laser radiation was attenuated to between 60 and 120 mW before focusing. We found through simple trial-and-error that these powers yielded groove widths that were approximately 1/2 a grating period. This ratio was chosen because for binary amplitude gratings the first-order diffraction efficiency \( \eta(R) = \sin(\pi R) / \pi \) [17,19] (where \( R = Kd \) is the ratio of line-width to grating constant) is maximum for \( R = 1/2 \). Intensities in this power range were high enough to exceed the damage threshold of the gold and remove the reflective coating on the mirrors. The grating lines were etched as one continuous path, as shown in Fig. 4. The resulting laser-etched grating patterns are shown in Figs. 5a–5c for \( m = 1, 2, \) and 7. In Figs. 5d–5f the same etched patterns are shown again, together with the calculated lines from the skeleton equations (in red online, gray in print). The etched lines agree with these calculated lines.

As we expected, we had to move the laser focus sufficiently slowly over the gold surface to etch a continuous groove with our pulsed laser, which has a repetition rate of 1 kHz. If we set the speed too large we obtained a useless series of pits instead of a groove, as shown in Fig. 6, with each pit burned by a single pulse of the laser. To investigate the smoothness of our continuous grooves we recorded and analyzed close-up microscopic images of the gratings. Figure 7 gives a typical impression of the detailed...
groove shape. We investigated how the quality of the groove shape (its smoothness) depends on how fast the focus is moved over the surface to be etched, and also how it is affected by the power used.

To investigate the power dependence, we etched a mirror with $100 \text{ mW}$, and another with only $60 \text{ mW}$. For a representative groove segment of each mirror we then determined the spread in groove width. Using an edge-detection routine in MATLAB, we identified the groove edges (red curves, gray in print, in Figs. 8a and 8c mark the boundary between the gold and the groove), and we then sampled the groove width at regular intervals. The histograms in Figs. 8b and 8d show the distributions of groove widths we found. We define the groove smoothness as $S = 1 - \Delta d/d$ where $\Delta d$ is the full width at half-maximum of Gaussian fits to the histograms of Fig. 8, and $d$ is the average groove width. The groove for 100 mW (Fig. 8a) shows a larger spread in linewidth, $(d = 34.9 \mu m, \Delta d = 4.3 \mu m, S = 88\%)$, than the one for 60 mW $(d = 41.5 \mu m, \Delta d = 2.4 \mu m, S = 94\%)$. The difference in smoothness resulted from decreasing the laser power. We concluded that for 100 mW too much laser power was being delivered to the mirror to properly laser etch. This was also apparent in the debris field on the surface of the mirror after the etching process. In contrast, the 60 mW mirror had very little debris on its surface. In either case, the groove smoothness appears acceptable. MATLAB simulations showed that insufficient smoothness causes a noise background in the far field, but, for our case, only at an estimated intensity level of $-40$ to $-30 \text{ dB}$. This is accompanied by a loss of intensity in the vortex beam of no more than 5% of the ideal vortex intensity.

4. Performance of the Laser-Etched Gratings

We used several optical setups to experimentally demonstrate mode quality, angular dispersion compensation, and the maximum intensity the LG mirrors can withstand. In our first experiment we used a Michelson interferometer (Fig. 9) to observe the resulting intensity patterns and phases of the OVs produced from $m = 1, 2$, and 7 LG mirrors. A removable diverging lens, $L$, was placed in the reference arm that produces a reference beam having either a plane or spherical wavefront. The reference mirror $M_{ref}$ was mounted onto a translation stage to adjust for differences in optical path length between the two arms of the interferometer. A 50/50 beam splitter was used to split the incoming femtosecond radiation.

The setup was radiated with full laser power ($\sim 2.3 \text{ W}$). The reference arm was blocked with an opaque screen allowing only the vortex beam to emerge from the interferometer. The resulting vortex beam was sent through a 1 m focusing lens and images were observed in the focus using a CCD camera. We placed neutral-density filters in front of the camera to avoid damage. Images of vortices of charges 1, 2, and 7 are shown in Figs. 10a–10c. Removing the
opaque screen allowed the reference beam to pass through the interferometer with a planar wavefront. Interference with this wavefront resulted in an intensity pattern that mimics the LG mirror lines, seen in Figs. 10d–10f. Finally, by adding the diverging lens to the reference arm (as shown in Fig. 9), a spherical reference beam was allowed to interfere with the vortex beam, resulting in the spiral structures seen in Figs. 10g–10i.

The observed vortices in Figs. 10a–10c show non-zero intensity at their centers. This is due to angular dispersion resulting from the diffraction of broad-band (~20 nm) radiation [18]. To compensate this angular dispersion we used a folded version of our 2f–2f setup [15,16]. In this folded setup, Fig. 11, the radiation passes through the converging lens L1 twice and there is a negligible distance (~150 μm) between the lens L1 and the folding mirror M. Therefore, if we mentally unfold the setup the effective focal length, \( f_{\text{eff}} \), follows from

\[
\frac{1}{f_{\text{eff}}} = \frac{1}{f} + \frac{1}{f} = \frac{2}{f} = \frac{2}{50} = 0.04 \text{cm},
\]

and so we adjusted the distance between the LG mirror and the L1/M to 100 cm = 2\( f_{\text{eff}} \). When compensating the angular dispersion, we used our Spectra-Physics Tsunami oscillator, whose bandwidth (~45 nm) is about twice that of the amplified beam (~20 nm). Pulse durations for the oscillator were determined to be ~110 fs from frequency-resolved optical gating (FROG) measurements. This pulse duration is not transform-limited due to pulse stretching by the final
cavity optics. (An external compressor would compress the pulse.) The resulting ±1 diffraction orders emerging from the folded 2f–2f setup show compensated (Figs. 12a–12c) and uncompensated (Figs. 12d–12f) vortex profiles. The uncompensated −1 order has twice the angular chirp that it would have had if it had been diffracted by only one grating [15]. Finally, a pinhole was placed in the zero-order beam to create a spherical reference beam. The resulting interferograms, shown in Figs. 12g–12i, confirm the topological charge we etched.

To determine the maximum intensity that the LG mirrors can withstand before becoming irreversibly damaged, an LG mirror was placed on an optical track so that it could be moved along the optical axis of a 1 m focusing lens. The lens focused 800 nm radiation from our Ti:sapphire laser amplifier having a pulse duration of ~50 fs. At a laser intensity of about $10^{12}$ W/cm$^2$, self-focusing was observed in the quartz glass behind the reflective surface of the LG grating. The intensity was increased by moving the LG mirror further into the focus. It was observed that the reflective gold coating became damaged at intensities $>10^{13}$ W/cm$^2$. This value is in agreement with [23]. To ensure that the LG mirror could withstand these intensities for long periods of time, the mirror was left for 30 min at slightly less than $10^{12}$ W/cm$^2$. Microscope observations revealed no damage to the LG mirror after this exposure.

Inspection of the images in Fig. 12 shows that the LG mirrors produce vortices of the correct topological charge. Also, the angular chirp they produce can be compensated using existing methods. Thus, we made fully functional vortex-producing gratings based on the skeleton equations we presented in Section 2. The scattered light seen in Fig. 12 must be at least in part due to the nonperfect groove smoothness of our laser-etched holograms. This background noise causes the vortex of charge 2 that was expected in Fig. 12b to split into two adjacent vortices of charge 1 [7]. It also leads to a nonzero intensity in the heart of the vortex of charge 7 in Fig. 12c. Improvement of the smoothness is expected to improve the quality of the vortices we produce.

5. Conclusions and Outlook

In conclusion, we have demonstrated a simple and straightforward way to produce optical vortices by laser etching grating lines into typical laser-quality gold mirrors. We have shown that these LG mirrors are sufficiently smooth and withstand high intensities. Their gold plating also allows for large bandwidths, making them suitable for a broad range of applications. Future experiments will involve laser etching silver and dielectric mirrors. In addition, improvement can be made to increase the efficiency of these LG mirrors and/or setups in which they are used when producing femtosecond optical vortices. First, it has been shown that small misalignments to a compressor allow precompensation of angular dispersion [16]. The elimination of the first grating pass in the 2f–2f setup increased the efficiency by an order of magnitude when binary gratings were used. Second, binary blazing techniques [24] might improve the first-order diffraction efficiency by an additional factor of 4. With these techniques, laser-etched LG mirrors would remain suitable for large bandwidth pulses in a wide range of optical wavelengths while retaining much of the power in the compensated order. Finally, it has been shown [25] that in the production of white-light Bessel beams, axicons are not suitable. The method outlined in this paper is highly applicable in the generation of high-power, broadband Bessel beams.

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